



PATENT

Customer No. 22,852

Attorney Docket No. 07553.0028

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Ken KOBAYASHI et al.

Application No.: 10/069,208

Filed: February 22, 2002

For: METHOD OF ETCHING

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) Group Art Unit: 1746
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) Examiner: Not assigned
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Commissioner for Patents
Washington, DC 20231

Sir:

PRELIMINARY AMENDMENT

Prior to the examination of the above application, please amend this application as follows:

IN THE SPECIFICATION:

Please amend the specification as follows:

Please delete page 17 in its entirety.

IN THE CLAIMS:

Please cancel claims 1-5 without prejudice or disclaimer, and add new claims 6-15, as follows:

6. (New) A method of etching an organic film on a workpiece, the organic film having an etching mask, the method comprising:

placing the workpiece in a hermetically sealed process chamber;